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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Takashi YOSHITOMI et al.
Serial No. : 10/619,394
Filed : July 15, 2003
For : **SEMICONDUCTOR DEVICE WITH CAPACITOR AND
PROCESS FOR MANUFACTURING THE DEVICE**
Examiner : Christian D. Wilson
Group Art Unit : 2824

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INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Further to the Information Disclosure Statements filed on July 15, 2003 and March 9, 2004, the Examiner's attention is respectfully invited to review the accompanying form PTO-1449 along with a copy of the reference identified therein.

FOREIGN DOCUMENTS

1. Korean Patent Application Laid Open No. 2000-10154, Published February 15, 2000 (Abstract in English also enclosed).

REMARKS

This document was cited in an Office Action dated July 8, 2004 by the Korean Intellectual Property Office in the corresponding Korean patent application, Application No. 10-2002-0012182 (copy of July 8, 2004 Korean Office Action and English translation attached). This Korean application is also assigned to Kabushiki Kaisha Toshiba.

The document cited in the previous Supplemental Information Disclosure Statement filed March 9, 2004 in the present U.S. application, Japanese Patent Application Laid Open No. 8-111377, was also cited in this July 8, 2004 Korean Office Action and a prior Korean Office Action dated December 12, 2003 in the same corresponding Korean patent application (copy of prior December 12, 2003 Korean Office Action and English translation also attached).

Pursuant to Rule 37 C.F.R. § 1.97(c), an Information Disclosure Statement shall be considered by the Patent Office if filed before the mailing date of either a Final Office Action under 37 C.F.R. § 1.113, or a Notice of Allowance 37 C.F.R. § 1.311, which ever occurs first, and is accompanied by the fee set forth in 37 C.F.R. § 1.17(p) for \$180.00.

This Supplemental Information Disclosure Statement is not a representation that the document cited herein is considered most pertinent, or that a search has been undertaken, or that the cited document is indeed prior art. The Examiner is respectfully invited to undertake an independent search.

Applicants respectfully request that the Examiner consider and make of record the document cited herein and that a copy of Form PTO-1499, appropriately initialed by the Examiner be returned to Applicants' attorney.

It is believed that no additional fee besides the \$180.00 is due; however, the Commissioner is hereby authorized to charge any additionally required fee or credit any overpayment therein to Deposit Account No. 50-0320.

Respectfully submitted,

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* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.